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<i>Application Number</i>	10/524,610
<i>International Filing Date</i>	August 11, 2005
<i>First Named Inventor</i>	Franz LAERMER
<i>Art Unit</i>	2818
<i>Examiner Name</i>	Hoang Quan Tran Ho

Attorney Docket Number 10191/4116

U.S. PATENT DOCUMENTS					
Examiner Initials *	Cite No. ¹	Document Number Number - Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS					
Examiner Initials *	Cite No. ¹	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		JP 7-106328	April 21, 1995		T ⁶
		JP 10-74755	March 17, 1998		*
				.	*

* English language abstract provided.

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			
		T. Homma, "Fluorinated interlayer dielectric films in ULSI multilevel interconnections", Journal of Non-Crystalline Solids, 1995, 187, pgs. 49-59			T ²
		T. Homma, "Stability of a new polyimide siloxane film as interlayer dielectrics of ULSI multilevel interconnections", Thin Solid Films, November 25, 1993, Vol. 235, Issues 1-2, pages 80-85. Provided is abstract thereof.			
		T. Homma, "Electrical stability of polyimide siloxane films for interlayer dielectrics in multilevel interconnections", Thin Solid Films, 1999, Vol. 340, pgs. 237-241			
		Nguyen Nhu Toan, "Spin-on-glass materials and applications in advanced IC technologies", 1999, retrieved from the Internet, URL: http://doc.utwente.nl/1409/			

Examiner Signature	Date Considered
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